

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Mong-Song Liang

Serial No. Unknown

Filed: Herewith

For: Integrated Treatment Method for Obtaining  
Robust Low Dielectric Constant Materials

§  
§  
§  
§  
§  
§  
§

Group Art Unit: Unknown

Examiner: Unknown

**INFORMATION DISCLOSURE STATEMENT**

Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In compliance with the duty of disclosure under 37 CFR §1.56, and in accordance with the practice under 37 CFR §1.97 and §1.98, the Examiner's attention is directed to the documents listed on the enclosed modified Form PTO-1449. No inference should be made that the cited references are in fact material, are in fact prior art, or that no better art exists. The cited patents are listed in numerical order and are not in any order based on their pertinence.

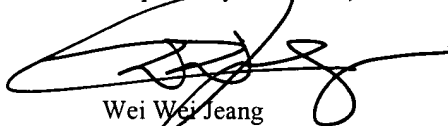
The above-identified application is being filed after June 30, 2003. Therefore, pursuant to the waiver of the requirement under 37 CFR 1.98 (a)(2)(i) as stated in a Pre-OG Notice dated July 11, 2003, copies of only the foreign patent documents and non-patent literature listed on the enclosed modified Form PTO-1449 are attached.

This Information Disclosure Statement is being filed within three months of the United States filing date or before the mailing date of a first Office Action on the merits. No certification or fee is required (37 CFR §1.97(b)).

The Commissioner is hereby authorized to charge any additional fees which may be required or credit any overpayment to Deposit Account 08-1394.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Respectfully submitted,



Wei Wei Jeang  
Registration No. 33,305

Date: March 26, 2004  
HAYNES AND BOONE, LLP  
901 Main Street, Suite 3100  
Dallas, Texas 75202-3789  
Telephone: 972-739-8631  
Facsimile: 214-200-0853  
File:

R-70738.1

**Certificate of Mailing**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on March 26, 2004

Bonnie Boyle  
Printed Name

Bonnie Boyle  
Signature

In place of PTO-1449 Form		U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		Complete if Known	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(use as many sheets as necessary)</i>				Application Number	
				Filing Date	
				Applicant(s)	Mong-Song Liang
				Art Unit	
				Examiner Name	
SHEET	1	OF	1	Attorney Docket Number	24061.197

U. S. PATENT DOCUMENTS				
Examiner's Initials	Cite No.	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
	AA	6,383,951	05-07-2002	Li
	AB	6,465,372	10-15-2002	Xia et al.
	AC	6,486,061	11-26-2002	Xia et al.
	AD	6,559,070	05-06-2003	Mandal
	AE	6,583,046	06-24-2003	Okada et al.
	AF	6,583,048	06-24-2003	Jean Louis Vincent et al.
	AG	6,635,575	10-21-2003	Xia et al.
	AH	2003/0008528	01-09-2003	Xia et al.
	AI	2003/0077857	04-24-2003	Xia et al.
	AJ	2003/0100691	05-29-2003	Lee et al.
	AK	2003/0198742	10-23-2003	Vrtis et al.
	AL	2003/0211244	11-13-2003	Li et al.
	AM	2003/0232137	12-18-03	Vrtis et al.
	AN	2003/0232495	12-18-03	Moghadam et al.

FOREIGN PATENT DOCUMENTS					
Examiner's Initials	Cite No.	Foreign Patent Document (Country Code - Number - Kind)	Publication Date MM-DD-YYYY	Patentee or Applicant of Cited Document	Translation Y/N

OTHER PRIOR ART		
Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume- issue number(s), publisher, city/country where published
	AO	"IITC 2003: Searching for Better Low-K Solutions", June 16, 2003, 2 pages, V10n24, JSR Micro Materials Innovation

Examiner Signature		Date Considered	
-----------------------	--	--------------------	--

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.